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Bib Data Sheet

CONFIRMATION NO. 7422

SERIAL NUMBER 10/680,216	FILING DATE 10/08/2003 RULE	CLASS 134	GROUP ART UNIT 1746	ATTORNEY DOCKET NO. P8375.0002
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** CONTINUING DATA *****

** FOREIGN APPLICATIONS *****

JAPAN 2002-303629 10/17/2002

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 12/31/2003

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 14	TOTAL CLAIMS 13	INDEPENDENT CLAIMS 2
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature <i>[Signature]</i>	Initials <i>[Initials]</i>		

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TITLE

Method of manufacturing semiconductor device and apparatus for cleaning substrate

FILING FEE RECEIVED	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
		<input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)